Primary MRSEC Support

IRG1


IRG2


**IRG3**


**IRG4**

None

**Partial MRSEC Support**

**IRG1**


**IRG2**


IRG3


**IRG4**


**Seed**


**Shared Facilities**


Patents


D.E. Morse, K.M. Roth, “Low-cost method for the fabrication of nanostructured semiconducting, photoconductive, photovoltaic, optoelectronic and electrical battery thin films and materials at low temperature, with no molecular template and no organic contaminants,” Provisional Patent granted 10/16/04.
